

Plnano[®] Trak Piezo Tracking System

Fast XY(Z) Stage for High Dynamics Microscopy



P-545.3D8S

- Fast response time <5 ms with subnanometer resolution: Ideal for tracking
- Including E-727 USB controller and software
- Travel ranges to 70 μm \times 70 μm \times 50 μm
- Low profile for easy integration: 20 mm
- Recessed sample holders, freely revolving nosepiece
- Extensive optional accessories
- Cost-optimized design

Fields of application

- Tracking
- High-resolution microscopy
- Inverse microscopy
- Screening
- Confocal microscopy
- Biotechnology

Outstanding lifetime thanks to PICMA[®] piezo actuators

The patented PICMA[®] piezo actuators are all-ceramic insulated. This protects them against humidity and failure resulting from an increase in leakage current. PICMA[®] actuators offer an up to ten times longer lifetime than conventional polymer-insulated actuators. 100 billion cycles without a single failure are proven.

High guiding accuracy due to zero-play flexure guides

Flexure guides are free of maintenance, friction, and wear, and do not require lubrication. Their stiffness allows high load capacity and they are insensitive to shock and vibration. They are 100 % vacuum compatible and work in a wide temperature range.

Extensive software for rapid start of productive operation

Thanks to support of MATLAB and NI LabVIEW as well as all common operating systems (Windows, Linux, and macOS), integration succeeds in virtually every environment – quickly and efficiently. Sophisticated programming examples and software tools such as PIMikroMove shorten the time to productive operation considerably.

Specifications

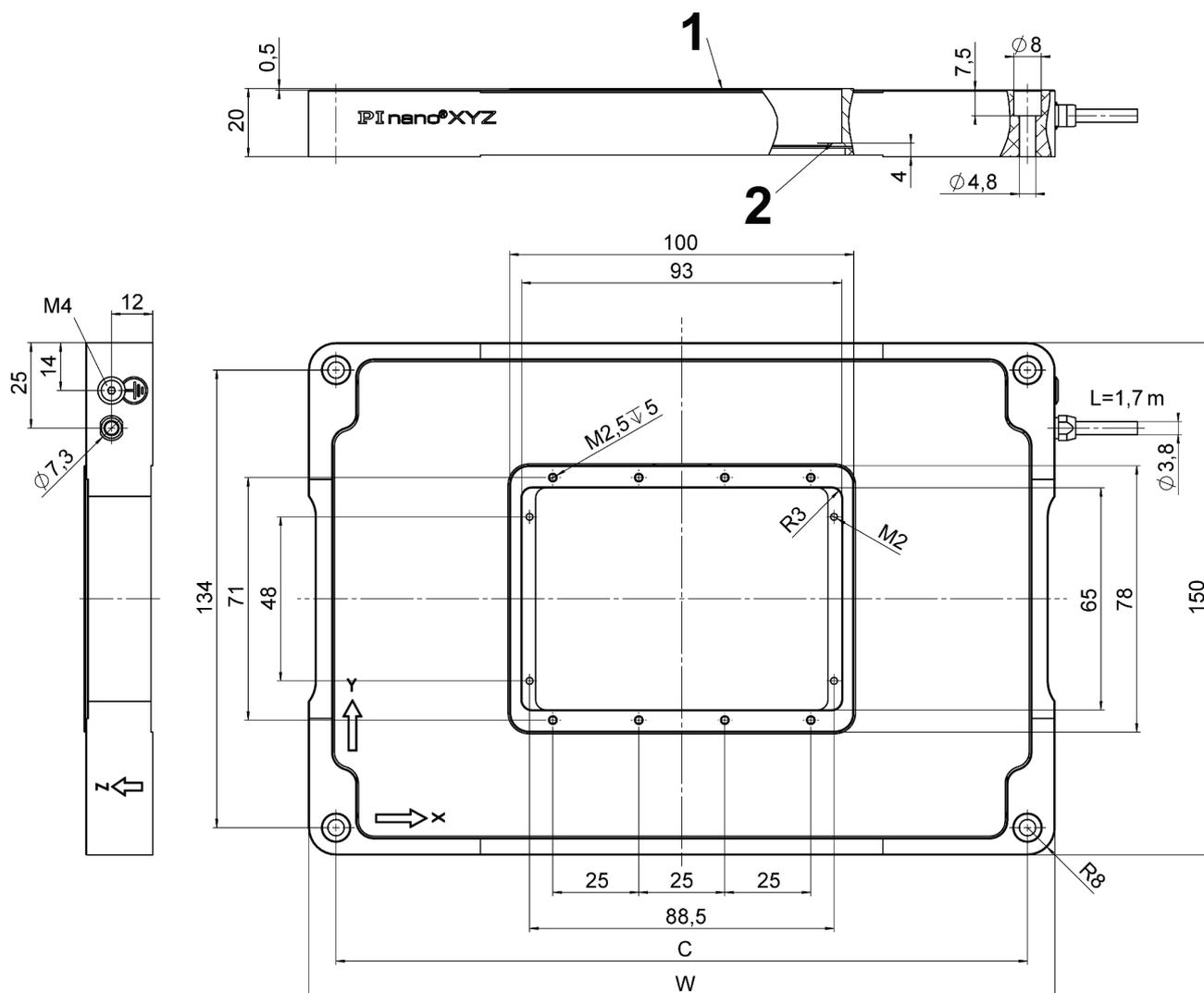
	P-545.3D8S	Unit	Tolerance
Active axes	X, Y, Z		
Motion and positioning			
Integrated sensor	Piezoresistive		
Travel range, closed loop	70 × 70 × 50	µm	
Resolution, closed loop*	<1	nm	typ.
Mechanical properties			
Resonant frequency, no load	1 (X, Y), 0.8 (Z)	kHz	
Push/pull force capacity	100 / 30	N	max.
Recommended load**	0.5	kg	max.
Drive properties			
Piezo ceramic	PICMA®		
Electrical capacitance	12 (X, Y), 24 (Z)	µF	±20 %
Miscellaneous			
Operating temperature range	15 to 40	°C	
Material	Aluminum		
Mass	1.2	kg	±5 %
Cable length	1.7	m	+10 cm
Piezo controller	E-727.3RDA (in the scope of delivery)		
Communication interfaces	Ethernet, USB, RS-232, serial SPI high-speed interface		
Analog input / Analog output	Sub-D 15 Input via 18-bit A/D converter Output via 20-bit D/A converter		
Command set	PI General Command Set (GCS)		
User software	PIMikroMove		
Software drivers	NI LabVIEW drivers, shared libraries for Windows and Linux		
Supported functions	Wave generator, data recorder, drift compensation, macros		

* The resolution of the system is limited only by the noise of the amplifier and the measuring technology because PI piezo nanopositioning systems are free of friction.

** For dynamic operation. Higher dynamics are possible with a reduced load.

All specifications based on room temperature (22 °C ±3 °C).

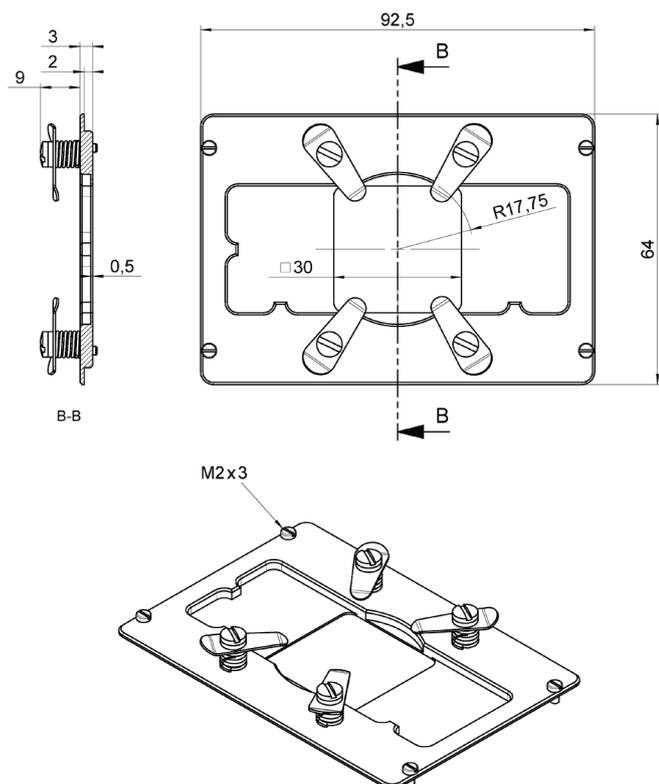
Drawings / Images



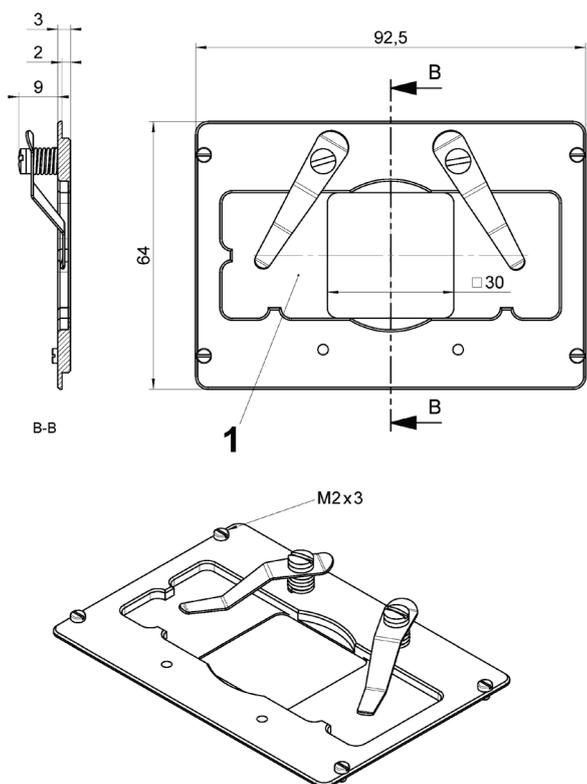
P-545.xx8S, dimensions in mm. P-545.3x8S: W = 217, C = 201. P-545.2x8S: W = 182, C = 166.

1: Upper mounting surface of the motion platform

2: Lower mounting surface of the motion platform



Accessories: P-545.PD3, Petri dish holder, dimensions in mm



Accessories: P-545.SH3, microscope slide holder, dimensions in mm

1: Recess for standard microscope slides (25 mm × 75 mm)

Ordering Information

P-545.3D8S

High dynamics PI nano[®] XYZ piezo system, clear aperture for microscope slides, 70 µm × 70 µm × 50 µm, direct drive, piezoresistive sensors, with USB digital controller

Accessories

P-545.PD3

Petri dish holder, 35 mm, for PI nano[®] piezo stages

P-545.SH3

Microscope slide holder for PI nano[®] piezo stages

P-545.C18

Coverslip holder with opening for coverslips 18 mm × 18 mm, suitable for P-545.SH3

P-545.C22

Coverslip holder with opening for coverslips 22 mm × 22 mm, suitable for P-545.SH3

P-545.C25

Coverslip holder with opening for coverslips 25 mm × 25 mm, suitable for P-545.SH3

P-545.PP3

Universal holding plate for accessory for PI nano[®] piezo stages

M-545.2MO

XY stage, 25 mm × 25 mm, micrometer drive, high stability, compatible with PI piezo stages, for Olympus microscopes (IX2, IX3)

M-545.2MN

XY stage, 25 mm × 25 mm, micrometer drive, high stability, compatible with PI piezo stages, for Nikon microscopes (TI series)

M-545.2ML

XY stage, 25 mm × 25 mm, micrometer drive, high stability, compatible with PI piezo stages, for Leica microscopes (DMI series)

M-545.2MZ

XY stage, 25 mm × 25 mm, micrometer drive, high stability, compatible with PI piezo stages, for Zeiss microscopes (Axio Observer)